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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Antonio L. P. Rotondaro Docket No: TI-31133
Serial No: 10/001,483 Conf. No: 1903
Examiner: Michelle Estrada Art Unit: 2823
Filed: 11/01/2001
For: METHOD TO IMPROVE THE UNIFORMITY AND REDUCE THE SURFACE ROUGHNESS
OF THE SILICON DIELECTRIC INTERFACE

AMENDMENT UNDER 37 C.F.R. § 1.111

Assistant Commissioner For Patents
Washington, DC 20231

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)
I hereby certify that the above correspondence is being
deposited with the U.S. Postal Service with sufficient
postage as First Class Mail in an envelope addressed to:
Assistant Commissioner for Patents, Washington, DC
20231 on 8-19-02.

Ann Trent
Ann Trent

Dear Sir:

Responsive to the Office Action mailed May 30, 2002, in connection with the
above identified application, Applicant respectfully submits the following amendments
and remarks.

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